



Ref. Certif. No.

**US-34924-UL**

**IEC SYSTEM FOR MUTUAL RECOGNITION OF TEST CERTIFICATES FOR ELECTRICAL EQUIPMENT (IECEE)  
CB SCHEME**

**CB TEST CERTIFICATE**

Product

Industrial LCD and Accessory Keyboards

Name and address of the applicant

HOPE INDUSTRIAL SYSTEMS INC  
1325 NORTHMEADOW PKWY  
ROSWELL GA 30076-3896 USA

Name and address of the manufacturer

HOPE INDUSTRIAL SYSTEMS INC  
1325 NORTHMEADOW PKWY  
ROSWELL GA 30076-3896 USA

Name and address of the factory

HOPE INDUSTRIAL SYSTEMS INC  
1325 NORTHMEADOW PKWY ROSWELL GA 30076-3896  
USA

Note: When more than one factory, please report on page 2

Additional Information on page 2

Ratings and principal characteristics

Models HIS-UM15, HIS-UM17, HIS-UM19, HIS-UM19.5,  
HIS-UM22, HIS-UM23: 100 – 240 VAC, 1.5-0.75 A, 60/50 Hz or  
9.6 – 36.6 VDC, 2.5 – 0.65 A

Trademark / Brand (if any)

Hope Industrial Systems Inc.



Type of Customer's Testing Facility (CTF) Stage used

Model / Type Ref.

LCD Monitors HIS-UM15, HIS-UM17, HIS-UM19.5, HIS-UM19,  
HIS-UM22, HIS-UM23  
All models may be provided with a suffix consisting of a dash (-)  
followed by four letters A through Z.

Additional information (if necessary may also be reported on page 2)

Additionally evaluated to EN 62368-1:2014 / A11:2017; National Differences specified in the CB Test Report.

Additional Information on page 2

A sample of the product was tested and found to be in conformity with

IEC 62368-1:2014

As shown in the Test Report Ref. No. which forms part of this Certificate

E212889-A6002-CB-1 issued on 2019-12-05

This CB Test Certificate is issued by the National Certification Body



- UL (US), 333 Pfingsten Rd IL 60062, Northbrook, USA
- UL (Demko), Borupvang 5A DK-2750 Ballerup, DENMARK
- UL (JP), Marunouchi Trust Tower Main Building 6F, 1-8-3 Marunouchi, Chiyoda-ku, Tokyo 100-0005, JAPAN
- UL (CA), 7 Underwriters Road, Toronto, M1R 3B4 Ontario, CANADA

For full legal entity names see [www.ul.com/ncbnames](http://www.ul.com/ncbnames)

Date: 2019-12-06

Signature:

Jolanta M. Wroblewska